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PATENT
Attorney Docket No. 04329.3180

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Shoji MIMOTOGL et al.)	Group Art Unit: 1756
)	
Serial No.: 10/705,954)	Examiner: Stephen D. Rosasco
)	
Filed: November 13, 2003)	Confirmation No.: 6725
)	
For: METHOD FOR EVALUATING)	
PHOTO MASK AND METHOD FOR)	
MANUFACTURING SEMICONDUCTOR)	
DEVICE)	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

REQUEST FOR RECONSIDERATION

In reply to the Office Action mailed August 29, 2006, the period to respond to which having been extended through December 29, 2006, by the attached Petition for Extension of Time and appropriate fee payment, Applicants request reconsideration based on the following remarks.

Remarks begin at page 2 of this paper.

Attachments include a terminal disclaimer as provided for under 37 CFR 1.321(c), a Petition for Extension of Time, and check in the amount of \$250.00